

U.S. Department of Commerce, Patent and Trademark Office LIST OF RELEVANT ART CITED BY APPLICANT (Use several sheets if necessary)					Docket No.: 3130/D1/TCG/PMD/LE	Serial No.: unknown		
					Applicants: Chen-An Chen and Won Bang			
					Filing Date: Herewith	Group:		
 1003 U.S. PTO 000283 07/10/01								
U.S. Patent Documents								
*Examiner Initial		Document Number	Issue Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>AA</i>	AA	3,175,567	03/30/65	Crawford				
<i>AB</i>	AB	3,409,031	11/05/68	Benbow et al.				
<i>AC</i>	AC	4,762,668	08/09/88	Loose et al.				
<i>AD</i>	AD	4,893,361	01/16/90	Burns				
<i>AE</i>	AE	5,085,244	02/04/92	Funk				
<i>AF</i>	AF	5,123,433	06/23/92	Fridsma et al.				
<i>AG</i>	AG	5,395,592	03/07/95	Bolleman et al.				
<i>AH</i>	AH	5,749,389	05/12/98	Ritrosi et al.				
<i>AI</i>	AI	5,968,588	10/1999	Sivaramakrishnan et al.				
<i>AJ</i>	AJ	4,684,104	08/1987	Micard				
<i>AK</i>	AK	5,925,189	07/1999	Nguyen et al.				
Foreign Patent Documents								
Translation								
		Document Number	Date	Country	Class	Subclass	Yes	No
<i>AL</i>	AL	DE 3714578 A1	11/12/87	Germany			Abstract only	
<i>AM</i>	AM	2 330 284	07/01/77	France			Abstract Only	
<i>AN</i>	AN							
<i>AO</i>	AO							
<i>AP</i>	AP							
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
<i>AR</i>	AR							
<i>AS</i>	AS							
<i>AT</i>	AT							
Examiner <i>J.C. Walker</i>		Date Considered <i>1/14/02</i>						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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Group:

U.S. Patent Documents

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JWY	AA	6,079,354	06/2000	Guo et al.			
JYJ	AB	4,566,416	01/1986	Berchtold			
JWY	AC	6,036,783	03/2000	Fukunaga et al.			
JWY	AD	4,103,827	08/1978	Kumazawa			
JWY	AE	5,962,085	10/1999	Hayashi et al.			
JYJ	AF	6,176,930	01/2001	Koai et al.			
JWY	AG	5,383,970	01/1995	Asaba et al.			
	AH						
	AI						
	AJ						
	AK						

Translation

Foreign Patent Documents

		Document Number	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

	AR	
	AS	
	AT	

Examiner *Amal M.* Date Considered *11/4/02*

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